

Application No. 10/696,989

MICI 1001-2

In the Specification:

Please replace paragraph [0072] with the following amended paragraph:

[0072] Fig. 8 is a simplified diagram of a production system for laser peening surfaces of work pieces using the present invention. The production system includes a relaxation pulse seeded master oscillator 300 implemented as described above with respect to Figs. 1-5. A preamplifier 301 amplifies the sequence of pulses on line 303 from the master oscillator 300. The output 304 of the preamplifier 301 ~~304~~ is applied to a power amplifier 302, such as the power amplifier described with reference to Fig. 7. High power pulses are applied on line 305.

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